



Image

1762 \$

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Paul B. Mirkarimi et al.

Docket No. : CIL-10972

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Art Unit : 1762

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Examiner : B. Pianalto

For : Ion-Assisted Deposition Techniques For  
The Planarization Of Topological Defects

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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